

Refine Search


Search Results -

Terms	Documents
L5 and ((retaining or support) near8 (nitride or nitrogen))	82

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L6  

Search History

DATE: Wednesday, May 24, 2006 [Printable Copy](#) [Create Case](#)

<u>Set</u> <u>Name</u> side by side	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Set</u> <u>Name</u> result set
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>			
<u>L6</u>	L5 and ((retaining or support) near8 (nitride or nitrogen))	82	<u>L6</u>
<u>L5</u>	L4 and L3	672	<u>L5</u>
<u>L4</u>	(etch\$ or remov\$) near6 oxide	160908	<u>L4</u>
<u>L3</u>	((retaining or support\$) same (etch\$ or remov\$) same (capacitor or storage node))	4883	<u>L3</u>
<i>DB=USPT; PLUR=YES; OP=ADJ</i>			
<u>L2</u>	L1 and ((retaining or support\$) same (etch\$ or remov\$))	77	<u>L2</u>
<u>L1</u>	438/397.ccls.	503	<u>L1</u>

END OF SEARCH HISTORY